



7-10-03
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Figura et al.

Serial No.: 09/471,460

Filed: December 22, 1999

For: USE OF A PLASMA SOURCE TO FORM A LAYER
DURING THE FORMATION OF A SEMICONDUCTOR DEVICE

§
§ Group Art Unit: 2825
§
§ Examiner: Calvin Lee
§
§ Atty. Docket: 94-0280.03
§
§ Paper No.
§

07/07/2003 GWORDDF1 00000001 133092 09471460 INFORMATION DISCLOSURE STATEMENT
01 FC:1806 180.00 DA

Certificate of Mailing (37 C.F.R. § 1.8)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

6/30/03 *Susan Jerome*
Date Signature

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, Applicants respectfully request that this Information Disclosure Statement be entered and that the references listed on the attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed references are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. § 1.97(b), this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possible material information as defined in 37 C.F.R. § 1.56(a) exists.

The following references are submitted for the Examiner's review:

U.S. Patents

<u>U.S. Patent No.</u>	<u>Issue Date</u>	<u>Inventor</u>
5,783,101	07/21/98	Ma et al.
5,565,384	10/15/96	Havemann
5,472,564	12/05/95	Nakamura et al.
5,419,822	05/30/95	Dakesian et al.
5,316,616	05/31/94	Nakamura et al.
5,164,332	11/17/92	Kumar

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Foreign Patents

<u>Number</u>	<u>Date</u>	<u>Country</u>
JP-06-275568	09/30/94	Japan
JP-01-149418	06/12/89	Japan
JP-62-032618	02/12/87	Japan
JP-62-030330	02/09/87	Japan
JP-59-103338	06/14/84	Japan

This Information Disclosure Statement is being submitted after the mailing of the first Office Action, but before the mailing of a Final Rejection or Notice of Allowance. The Commissioner is authorized to charge the fee set forth in 37 C.F.R § 1.17(p) of \$180 and any additional fees which may be required to Micron Technology Inc. Deposit Account No.13-3092, Order No. 94-0280.03.

If there are any matters which may be resolved or clarified through telephone interview, the Examiner is respectfully requested to contact Applicants' undersigned attorney at the number indicated.

* * * *

A Form PTO-1449 is enclosed herewith.

Respectfully submitted,



Date: 6/27/13

Charles Brantley
Reg. No. 38,086
Micron Technology, Inc.
8000 S. Federal Way
Boise, ID 83706-9632
(208) 368-4557
ATTORNEY FOR APPLICANTS